

PATENT

-1-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Kenneth C. Johnson et al.

Application No.: NEW

Filed: HEREWITH

For: METHOD OF MEASURING MESO-
SCALE STRUCTURES ON WAFERS

Group Art Unit: Unknown

Examiner: Unknown

SUBMISSION OF FORMAL DRAWINGS

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M/S PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

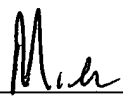
Sir:

Enclosed are nineteen (19) sheets of formal drawings for filing in the above-referenced application.

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: July 16, 2003

By: 
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